

**S/N 10/005667****PATENT****IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant:	Qing Ma	Examiner:	Jamie L. Brophy
Serial No.:	10/005667	Group Art Unit:	2822
Filed:	November 2, 2001	Docket No.:	884.591US1
Title:	METHOD OF FABRICATING AN INTEGRATED CIRCUIT HAVING A MEMS DEVICE		

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**AMENDMENT AND RESPONSE UNDER 37 CFR § 1.111**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Applicant has reviewed the Office Action mailed on May 23, 2003. Please amend the above-identified patent application as follows.

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TO: Examiner J. Brophy (Fax # 703-746-7409)

FROM: Andrew Peret

RE: 10/005,667

Here is a proposed Response for discussion purposes at our  
2:00 PM Eastern meeting on 7/1.

Regards,

Andrew Peret 262-646-7009

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